



Serial No. 10/712,100  
SKI.008C2

*Request for Reconsideration dated January 31, 2006*

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re PATENT APPLICATION of

Shunji Hayashi

Group Art Unit: 2125

Serial No.: 10/712,100

Examiner: K. Bahta

Filed: November 14, 2003

Confirm No.: 8230

For: METHOD AND SYSTEM FOR MANAGING SEMICONDUCTOR  
MANUFACTURING EQUIPMENT

**REQUEST FOR RECONSIDERATION**

U.S. Patent and Trademark Office  
Customer Window, Mail Stop AF  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Date: January 31, 2006

Sir:

In response to the Final Office Action dated November 3, 2005, the following  
remarks are respectfully submitted in connection with the above-identified application.

**Remarks/Arguments begin on page 2 of this paper.**